

#4
B5
4-29-03

Applicant(s)	Richard Nichols	INFORMATION DISCLOSURE STATEMENT RECEIVED APR 22 2003
Serial No.	10/087,610	
Filing Date	March 1, 2002	
Examiner Name	Unknown	
Group Art Unit	2182	
Confirmation No.	7953	
Attorney Docket No.	100.152US01	
Title: DIGITAL PLL WITH CONDITIONAL HOLDOVER		Technology Center 2100

Commissioner for Patents
Washington, D.C. 20231


In compliance with 37 C.F.R. § 1.56, and in accordance with 37 CFR § 1.97, *et seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicant respectfully requests that this Information Disclosure Statement be entered and the documents listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions of MPEP §609, Applicant requests that a copy of the 1449 form, initialed as being considered by the Examiner, be returned to the Applicant with the next official communication.

As an Office Action has not yet issued in the application, it is believed that no fee is due; however, should fees be required, the Commission for Patents is hereby authorized to charge any additional fees or credit any overpayments to Deposit Account No. 502432.

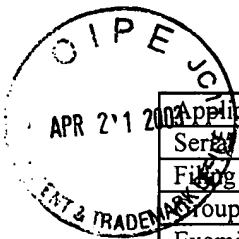
The Examiner is invited to contact the Applicant's representative at the below-listed telephone number if there are any questions regarding this communication.

Respectfully submitted,

Date: 4/18/2003


Laura A. Ryan
Reg. No. 49,055

Attorneys for Applicant
Fogg and Associates, LLC
P.O. Box 581339
Minneapolis, MN 55458-1339
T – (612) 332-4720
F – (612) 677-3553



Applicant(s)	Richard Nichols	INFORMATION DISCLOSURE STATEMENT FORM PTO-1449
Serial No.	10/087,610	
Filing Date	March 1, 2002	
Group Art Unit	2182	
Examiner Name	Unknown	
Attorney Docket No.	100.152US01	
Title: DIGITAL PLL WITH CONDITIONAL HOLDOVER		
Sheet 1 of 1		

U.S. Patent References				
Examiner Initials	Patent No.	Issue Date	Name	Filing Date
	5,317,601	05/31/1994	Riordan et al.	08/21/1992
	5,990,715	11/23/1999	Nishimura	04/16/1997
	5,994,934	11/30/1999	Yoshimura et al.	07/08/1998
	6,049,239	04/11/2000	Eto et al.	09/22/1997
	6,242,954	06/05/2001	Taniguchi et al.	08/27/1999
	6,313,676	11/06/2001	Abe et al.	03/16/2000
	6,323,705	11/27/2001	Shieh et al.	04/25/2000

Foreign Patent References					
Examiner Initials	Foreign Patent		Name	Publication Date	T?
	Country	No.			
	NONE				

Other References	
Examiner Initials	Author, Title, Date, Pages, etc.
	NONE

RECEIVED

APR 22 2003

Technology Center 2100

Examiner Signature		Date Considered	
*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			